



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No. .... 09/643,004  
Filing Date ..... August 21, 2000  
Inventor ..... Garry Anthony Mercaldi  
Assignee ..... Micron Technology, Inc.  
Group Art Unit ..... 2823  
Examiner ..... J. Maldonado  
Attorney's Docket No. .... MI22-1358  
Title: Low Selectivity Deposition Methods

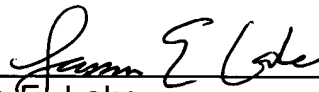
**SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT**

In compliance with 37 C.F.R. §§1.56, 1.97 and 1.98, your attention is directed to the U.S. Patents and other documents listed on the attached Form PTO-1449. No admission is made regarding whether the submitted references are prior art.

Citation of these references is respectfully requested.

Respectfully submitted,

Dated: 22 Nov 2005

By:   
James E. Lake  
Reg. No. 44,854

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Form PTO-1449		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTY. DOCKET NO. MI22-1358		SERIAL NO. 09/643,004	
LIST OF ART CITED BY APPLICANT (Use several sheets if necessary)				APPLICANT: Gary A. Mercaldi			
				FILING DATE August 21, 2000		GROUP 2823	

U.S. PATENT DOCUMENTS							
*Examiner's Initials	AA	Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate
	AA	2005/0124171 A1	06/2005	Vaartstra			
	AB	2005/0124158 A1	06/2005	Lopatin et al.			
	AC	2005/0124153 A1	06/2005	Cohen, Uri			
	AD	2005/0101119 A1	05/2005	Li et al.			
	AE						
	AF						
	AG						
	AH						
	AI						

FOREIGN PATENT DOCUMENTS							
	AJ	Document Number	Date	Country	Class	Subclass	Translation
	AJ						Yes No
	AK						
	AL						

OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)			
	AM		
	AN		
	AO		

EXAMINER	DATE CONSIDERED
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\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

EV 633203594